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Day: Friday Date: 9/24/2004

Time: 09:49:35

Inventor Name Search Result

Your Search was:

Last Name = PYO First Name = SUNG 09/879,204

Application#	Patent#	Status	Date Filed	Title	Inventor Name 33
10878315	Not Issued	030	06/29/2004	RADIO FREQUENCY SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME	PYO, SUNG GYU
10878314	Not Issued	020		METHOD FOR FORMING INDUCTOR IN SEMICONDUCTOR DEVICE	PYO, SUNG GYU
10731478	Not Issued	030		METHOD FOR FORMING INDUCTOR IN SEMICONDUCTOR DEVICE	PYO, SUNG GYU
10697320	Not Issued	030	10/31/2003	CU FILM DEPOSITION EQUIPMENT OF SEMICONDUCTOR DEVICE	PYO, SUNG GYU
10162873	Not Issued	041	06/06/2002	CHEMICAL ENHANCER TREATMENT CHAMBER AND A CU, THIN FILM DEPOSITION APPARATUS OF A SEMICONDUCTOR DEVICE USING THE SAME	PYO, SUNG GYU
10157137	Not Issued	092		METHOD FOR FORMING DIFFUSION BARRIER FILM OF SEMICONDUCTOR DEVICE	PYO, SUNG GYU
10156839	6664636	150		CU FILM DEPOSITION EQUIPMENT OF SEMICONDUCTOR DEVICE	PYO, SUNG GYU
10079115	6617238	150		METHOD OF MANUFACTURING A METAL WIRING IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
09983668	6551932	150		METHOD FOR FORMING METAL LINE IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU

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09888539	6528415	150	06/26/200	METHOD OF FORMING A METAL LINE IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
09883964	6627523			METHOD OF FORMING A METAL WIRING IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
09883242	Not Issued	161	06/19/2001	SHOWERHEAD AND LIQUID RAW MATERIAL SUPPLY APPARATUS USING THE SAME	PYO, SUNG GYU
<u>09880816</u>	6468907	150	06/15/2001	METHOD OF MANUFACTURING A COPPER WIRING IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
09880815	6413864	150	06/15/2001	METHOD OF MANUFACTURING A COPPER METAL WIRING IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
09880810	Not Issued	161	06/15/2001	SHOWERHEAD IN CHEMICAL-ENHANCED CHEMICAL VAPOR DEPOSITION EQUIPMENT	PYO, SUNG GYU
09879324	Not Issued	161	06/12/2001	METHOD OF MANUFACTURING A METAL LINE IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
09879204	Not Issued	030	06/13/2001	HEATER BLOCK HAVING CATALYST SPRAY MEANS	PYO, SUNG GYU
09875698	6723645	150		METHOD OF FORMING A METAL WIRING IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
09875625	6645858	150		METHOD OF CATALYZING COPPER DEPOSITION IN A DAMASCENE STRUCTURE BY PLASMA TREATING THE BARRIER LAYER AND THEN APPLYING A CATALYST SUCH AS IODINE OR IODINE COMPOUNDS TO THE BARRIER LAYER	PYO, SUNG GYU
09875623	6436826	150		METHOD OF FORMING A METAL WIRING IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
<u>09875621</u>	6376356	150		METHOD OF MANUFACTURING A METAL WIRING IN A	PYO, SUNG GYU

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				SEMICONDUCTOR DEVICE	
09874505	6593236	150	06/05/200	1 METHOD OF FORMING A METAL WIRING IN A SEMICONDUCTOR DEVICE WITH COPPER SEED	PYO, SUNG GYU
09837595	6553859	150	04/18/200	POWER SHIFT DEVICE OF TRANSMISSION FOR VEHICLE	PYO, SUNG-YONG
09821979	Not Issued	161	03/30/200	APPARATUS FOR SUPPLYING A LIQUID RAW MATERIAL AND METHOD OF MANUFACTURING A COPPER LAYER USING THE SAME	
09722031	Not Issued	161	11/27/2000	DUPLEX ZONE SHOWERHEAD AND CHEMICAL ENHANCED CHEMICAL VAPOR DEPOSITION EQUIPMENT UTILIZING THE SAME	PYO, SUNG GYU
09721968	6337276		11/27/2000	METHODS OF FORMING A COPPER WIRING IN A SEMICONDUCTOR DEVICE USING CHEMICAL VAPOR DEPOSITION	PYO, SUNG GYU
09721967	6492268	150	11/27/2000	METHOD OF FORMING A COPPER WIRING IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
09704741	Not Issued	161	,	METHOD OF FORMING A METAL WIRING IN A SEMICONDUCTOR	PYO, SUNG GYU
09488521	6346478	150		METHOD OF FORMING A COPPER WIRING IN A SEMICONDUCTOR DEVICE	PYO, SUNG GYU
09428049	6349887	150	10/27/1999	LIQUID DELIVERY SYSTEM	PYO, SUNG GYU
08605206	Not Issued	161	12/05/1996	NOVEL THIAZOLIDIN-4-ONE DERIVATIVES	PYO , SUNG S.
08500799	Not Issued	161	07/11/1995	GRANULOCYTE ASSAY METHODS AND APPARATUS	PYO , SUNG H.
08366594	<u>5541183</u>	150	12/29/1994	GINKGOLIDE DERIVATIVES	PYO, SUNGSOO

Inventor Search Completed: No Records to Display.

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